


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Young Sun Hwang et al.)	I hereby certify that this paper and the
)	documents referred to as enclosed
Serial No.: To be assigned)	therewith are being deposited with the
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Photoresist Patterns)	1450, Alexandria, Virginia 22313-1450
)	
Group Art Unit: To be assigned)	Michael R. Hull
)	Reg. No. 35,902
Examiner: To be assigned)	Attorney for Applicant
)	
)	
)	

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
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Sir:

Submitted herewith for consideration by the examiner is a copy of the document identified on the attached Form PTO-1449. Entry and consideration of the submitted document is solicited.

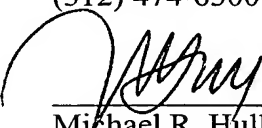
The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 13-2855.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP
6300 Sears Tower
233 South Wacker Drive
Chicago, Illinois 60606-6357
(312) 474-6300

November 21, 2003

By:


Michael R. Hull
Reg. No. 35,902

Form PTO-1449 (Modified) U.S. Department of Commerce Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.	Serial No.
	30205/39513	To be Assigned
	Applicant	
	Young Sun Hwang et al.	
	Filing Date	Group
	November 21, 2003	To be Assigned

U.S. PATENT DOCUMENTS							
*Examiner Initials		Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate
		6,541,361 B2	04/01/2003	Ko et al.			

FOREIGN PATENT DOCUMENTS								
*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No
		11307437	11/05/1999	Japan			Abstract Only	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		

EXAMINER	DATE CONSIDERED
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